# **Supplementary Information**

## **Asymmetric Electric Field Screening in van der Waals**

### **Heterostructures**

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#### **Supplementary Note 1: Qualitative analysis on the EFM result**

 We tried to establish a qualitative agreement between the simulation and EFM experiment using very rough approximations. The most widely used simplified model to estimate EFM interactions is by Hudlet et al.<sup>1</sup> When the sample is completely flat and the cantilever tip has a cone shape, as well as the lever interaction is ignored, the electrostatic force can be simplified as:

$$
F = \pi \varepsilon \left[ \frac{R^2 (1 - \sin \theta_0)}{z [z + R(1 - \sin \theta_0)]} + \frac{1}{\left[ \ln \tan \left( \frac{\theta_0}{2} \right) \right]^2} \left( \ln \frac{z + R(1 - \sin \theta_0)}{H} - 1 + \frac{R \frac{\cos^2 \theta_0}{\sin \theta_0}}{z + R(1 - \sin \theta_0)} \right) \right] (V + V_{CPD})^2 \tag{1}
$$

where *F* is the electrostatic force felt by the conductive cantilever tip during measurements;  $\varepsilon$  is

the permittivity of the gap between the tip and sample; *R* is the radius of the apex of the tip;  $\theta_0$  is the angle between the tip apex and the tip cone; *z* is the distance between the tip apex and the flat sample; *H* is the height of the tip cone. *V* is the voltage applied to the substrate;  $V_{CPD}$  is the contact potential difference. The geometric parameters of the tip used in the calculation can be found in Supplementary Figure 1.



**Supplementary Figure 1: Schematic of the EFM tip.** Geometric parameters of the cantilever tip used in the simplified model to qualitatively analyze EFM interactions<sup>1</sup>.

Combining Eq.1, 2 and Supplementary Equation 1, we can calculate the electric susceptibility

based on the EFM results. The permittivity of the gap between the tip and the Au substrate is estimated by:

$$
\varepsilon = \kappa \varepsilon_0 = \frac{(t_1 + t_2)\kappa_1 \kappa_2}{t_1 \kappa_2 + t_2 \kappa_1} \varepsilon_0 \qquad (2)
$$

where  $\kappa$  is the relative permittivity of the gap;  $\kappa_1$  and  $\kappa_2$  are the relative permittivity of the heterostructure and air  $(\kappa_2=1)$ ;  $t_1$  and  $t_2$  are the thickness of the heterostructure and air between the tip and the sample. The thickness of 3L MoS2/4L Graphene is 3.29nm; the tip/sample distance is 8nm. However, due to the many unknown parameters in Supplementary Equation 1, we could not directly calculate the electric susceptibility of the heterostructures; instead, we use the difference between the left and right side of the asymmetric parabola (Figure 2) for calculating the change of the electric susceptibility of 3L MoS<sub>2</sub>/4L graphene, given  $\kappa_l$ =1.2 when the electric field goes in graphene and comes out from  $MoS<sub>2</sub>$ . The qualitative result as illustrated in Supplementary Figure 2 shows that there is a gradual increase in the electric susceptibility of the heterostructure as the bias points towards  $MoS<sub>2</sub>$  and more voltage is applied in EFM. The high-dispersion of points near 0 V is due to small tip voltage (*V*), giving rise to bad signal-tonoise ratio in electrostatic force and hence phase change.



**Supplementary Figure 2: Electric susceptibility from EFM data.** Estimated electric susceptibility  $\chi$  of 3L MoS<sub>2</sub>/4L Graphene under (a) positive and (b) negative voltages. Positive (negative) voltages go towards  $MoS<sub>2</sub>$  (Graphene) in EFM.

Note that the qualitative analysis is based on many rough approximations. For example, geometry has a critical effect on the EFM interactions, and in our experiment the cantilever tip has a non-conical or asymmetric shape<sup>2</sup>. However, there has been no simplified model suitable for such tip geometry.

#### **Supplementary Note 2: Interlayer distance between graphene and MoS<sub>2</sub> sheets**

We performed simulations using different van der Waals (vdW) density functional (DF) to clarify whether different approaches on the exchange potential would give different results on the interlayer distance between graphene and  $MoS<sub>2</sub>$  sheets. We have used the original Dion et al.  $vdW-DF<sup>3</sup>$  (DRSLL), with different modifications on the exchange part. They are those modified by K. Berland and P. Hyldgaard<sup>4</sup> (BH), by V. R. Cooper<sup>5</sup> (C09), and by J. Klimes, D. R. Bowler and A. Michaelides<sup>6</sup> (KBM). Supplementary Table 1 summarizes the main results obtained. We

found that despite the vdW-functional utilized minor modifications are noted at the interlayer distance between graphene and  $MoS<sub>2</sub>$  sheets. All three modifications on the exchange functional give results at the same magnitude, which differ by around 2% of the original DRSLL functional. Indeed, these values compare well to the recent literature also using similar setup and functionals<sup>7-8</sup>. This indicates that the choice of the vdW functional is not so critical on the description of the graphene-MoS<sub>2</sub> interface<sup>9</sup>.



**Supplementary Table 1:** Interlayer distance between graphene (G) and MoS<sub>2</sub> layers calculated using different van der Waals density functional (vdW-DF). The interlayer distance is taken from the carbon plane to the topmost S atom at the  $MoS<sub>2</sub>$  layer near to graphene.

We also estimate the effect of different interlayer distances on the results of the electrostatic model. We take the 1L Graphene/ 1L MoS<sub>2</sub> as an example, and analyze the charge density  $Q_G$  as a function of  $E_{\text{ext}}$ , as illustrated in Supplementary Figure 3. It is observed, that the choices of different vdW functionals have almost negligible influence on the results of the electrostatic model. Therefore, the conclusions using the electrostatic model remain valid, regardless of the vdW functionals used in the *ab initio* simulations.



**Supplementary Figure 3: Charge density calculated using different vdW functionals.**

Charge density  $Q_G$  as a function of  $E_{ext}$  of a 1L Graphene/ 1L MoS<sub>2</sub> configuration, with the interlayer distances estimated from different vdW functionals (DRSLL, BH, C09 and KBM). The different choices of vdW functionals show almost negligible influence on the electrostatic model.

#### **Supplementary References**

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